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** CONTINUING DATA *****

This application is a 371 of PCT/KR03/00786 04/17/2003

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 10-2002-0021554 04/19/2002

** SMALL ENTITY **

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4 ✓	TOTAL CLAIMS 13 ✓	INDEPENDENT CLAIMS 1 ✓
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>[Signature]</i> Examiner's Signature	<i>[Initials]</i> Initials			

ADDRESS

23413

TITLE

Apparatus and method for depositing thin film on wafer using remote plasma

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